

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application of:	HAGELIN et al.	Confirmation No.:	To be assigned
Serial No.:	To be assigned	Art Unit:	2872
Filed:	July 25, 2003	Examiner:	James Phan
For:	<i>Apparatus and Method for Optical Raster-Scanning in a Micromechanical System</i>	Attorney Docket No:	9875-0008-999

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This amendment is being filed along with the initial filing of this divisional application.

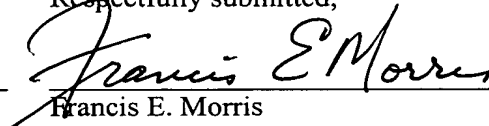
**IN THE CLAIMS:**

Please cancel claims 1-17 and add the following claim:

18. A micromechanical scanning device comprising:
- a first micromechanical mirror having a first radius of curvature value;
  - a first micromechanical drive mechanism configured to drive said first micromechanical mirror;
  - a second micromechanical mirror having a second radius of curvature value; and
  - a second micromechanical drive mechanism configured to drive said second micromechanical mirror;
- wherein said first micromechanical mirror is convex and said second micromechanical mirror is concave.

Respectfully submitted,

Date: July 25, 2003

  
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31,066